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Sheet 1 of 1

Form 1449*

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INFORMATION DISCLOSURE STATEMENT
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(Use several sheets if necessary)

Applicant: Leonard Forbes et al.

Filing Date: July 29, 1997

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U.S. PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
W.M.	4,113,515	09/12/1978	Kooi, E., et al.	148	1.5	03/29/76
	5,858,811	01/12/1999	Tohyama, S.	438	75	01/15/97
	6,144,581	11/07/2000	Diorio, C.J., et al.	365	185.03	11/30/98
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FOREIGN PATENT DOCUMENTS

**Examiner Initial	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
W.M.	01-115162	05/08/1989	Japan	H01L	29/78		
	0291951	11/23/1988	European	H01L	29/64		
	04-056769	02/24/1992	Japan	C23C	16/32		
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	63-219172	09/12/1988	Japan	H01L	29/78		
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OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

**Examiner Initial	
W.M.	Zirinsky, S., et al., "Electrical Resistivity of Amorphous Silicon Resistor Films", <u>Extended Abstracts of the Spring Meeting of the Electrochemical Society</u> , Washington, DC, pp. 147-149, (1971)

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Examiner William Mintel Date Considered 6/12/01

*Substitute Disclosure Statement Form (PTO-1449)

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